

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Small et al.
Title: Chemical-Mechanical Planarization Using Ozone
Serial No.: 10/783,651 Filed: February 19, 2004
Examiner: Unknown Group Art Unit: 1765
Docket No.: CHEM.010US1 Conf. No.: 7333

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 2/25/05

Gileen Bow
Signature

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application.

This Information Disclosure Statement replaces the previously-filed Information Disclosure Statement filed on February 19, 2004 for the above-referenced application. This Information Disclosure Statement contains all prior information contained in the February 19, 2004 Information Disclosure Statement, but is being resubmitted in a more conducive form for scanning by the USPTO.

Copies of the documents listed on the accompanying Form PTO-1449 that are not enclosed were previously submitted in Parent Application No. 09/783,069, filed February 13, 2001, which is relied upon for an earlier filing date under 35 U.S.C. Section 120.

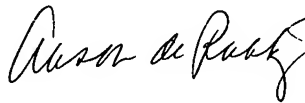
Copies of Other Art (Reference Nos. 36-38) listed on the accompanying Form PTO-1449 are enclosed.

Listing of these documents shall not be construed as:

1. an admission that any of these documents is necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that information in any of these documents is, or is considered to be, material to patentability as defined in § 1.56(b).

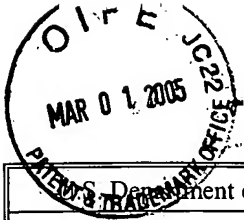
This information disclosure statement is submitted under 37 C.F.R. § 1.97(b) and consequently no fee should be required. The Commissioner is authorized, however, to charge any fee that may be required, or to credit any overpayment, against Deposit Account No. 502664. This form is being submitted in duplicate.

Respectfully submitted,



K. Alison de Runtz
Reg. No.: 37,119

PARSONS HSUE & DE RUNTZ LLP
655 Montgomery Street, Suite 1800
San Francisco, CA 94111
(415) 318-1160
(415) 693-0194 (Fax)



U.S. Department of Commerce, Patent and Trademark INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Atty. Docket No.	Application No.
	CHEM.010US1	10/783,651
	Applicant(s)	Conf. No.
(Use several sheets if necessary)	Small et al.	7333
(Form PTO-1449)	Filing Date	Group
	February 19, 2004	1765

U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	1	5,872,043	2/99	Chen			
	2	5,976,979	11/99	Chen			
	3	6,100,198	8/8/00	Grieger et al.			
	4	6,124,210	9/26/00	Chino et al.			
	5	6,001,730	12/99	Farkas et al.			
	6	6,110,830	8/00	Skrovan et al.			
	7	6,143,673	11/7/00	Jang et al.			
	8	6,123,602	9/26/00	Rodriguez et al.			
	9	6,115,862	9/12/00	Cooper et al.			
	10	6,110,431	8/29/00	Dunder			
	11	6,106,788	8/22/00	Rau et al.			
	12	6,072,226	6/6/00	Thakur et al.			
	13	6,037,251	3/14/00	Tu et al.			
	14	5,957,759	9/28/99	Cardenas et al.			
	15	5,926,722	7/20/99	Jang et al.			
	16	5,869,394	2/9/99	Chen et al.			
	17	5,869,384	2/9/99	Yu et al.			
	18	5,858,830	1/12/99	Yoo et al.			
	19	5,857,893	1/12/99	Olson et al.			
	20	5,837,612	11/17/98	Ajuria et al.			
	21	5,800,251	9/1/98	Nakazato et al.			
	22	5,672,539	9/30/97	Thakur et al.			
	23	5,270,241	12/14/93	Dennison et al.			
	24	5,162,248	11/10/92	Dennison et al.			
	25	4,059,929	11/29/77	Bishop			
	26	4,086,152	4/25/78	Rich et al.			
	27	4,064,660	12/27/77	Lampert			

U.S. Department of Commerce, Patent and Trademark				Atty. Docket No.		Application No.		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				CHEM.010US1		10/783,651		
				Applicant(s)		Conf. No.		
(Use several sheets if necessary)				Small et al.		7333		
(Form PTO-1449)				Filing Date		Group		
				February 19, 2004		1765		
U.S. Published Patent Application Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	28	2001/0027798A1	10/11/01	Flierl et al.				
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	29	08255791	10/1/96	Japan			Abstract only	
	30	11-87285	3/30/99	Japan			X*	
	31	11-87285	3/30/99	Japan			X**	
	32	00/17281	3/30/00	PCT				
	33	0 846 742 A2	10/6/88	EPO				
<p>* Computer-generated translation of 11-87285, previously disclosed.</p> <p>** Human-generated translation of 11-87285, previously disclosed.</p>								
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	34	International Search Report in PCT/US02/03453 of EKC Technology, Inc., mailed August 14, 2002, 7 pages.						
	35	Notification of Transmittal of the International Preliminary Examination Report and International Preliminary Examination Report of EKC Technology, Inc., mailed August 12, 2003, 6 pages.						
	36	Preliminary Examination Decision of Rejection, dated April 13, 2004, in Taiwanese Patent Application No. 91102249 of EKC Technology, Inc., 3 pages.						
	37	Translation of Preliminary Examination Decision of Rejection in Taiwanese Patent Application No. 91102249 of EKC Technology, Inc. dated April 13, 2004, 1 page.						
	38	Notification of First Office Action, dated January 7, 2005, in Chinese Patent Application No. 0285701.5 of EKC Technology, Inc., 5 pages.						
Examiner			Date Considered					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>								